MANUAL WAFER TRANSFER

1. Select Test Mode on the Main Control Panel
2. If F4 TRANS/TEST is not available select F12 RETURN
3. Select F4 TRANS/TEST
4. Select F3 TRANSPORTATION
5. In the WAFER TRANSPORTATION box select WAFER LOAD if you want to transfer from the Transfer Stage (the manual wafer loading station) to the process chamber or the WAFER UNLOAD if you want to move a wafer from the process chamber to the Transfer Stage.
6. Press the START button on the Main Control Panel.

The transfer is complete when the green LED is off on the Main Control Panel START BUTTON.

CAUTION: If a WAFER LOAD is selected while in Auto Mode, the current selected process recipe will automatically run after the transfer is complete.